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ICPE2024 in Numbers

50 Years from the first ICPE

657+ Participants (half from outside of Japan)

26 *Countries/ Regions*

434 *Papers/Presentations*

23 Organized Sessions

16 General Sessions

13 Premium Sponsors

12 Industrial Exhibitions

History of ICPE

ICPE1974	Tokyo	ICPE1976	Tokyo	ICPE1977	Kyoto
ICPE1980	Tokyo	ICPE1984	Tokyo	ICPE1987	Osaka
ICPE1994	Chiba	ICPE1997	Hokkaido	ICPE1999	Osaka
ICPE2001	Yokohama	ICPE2006	Tokyo	ICPE2008	Portland
ICPE2010	Singapore	ICPE2012	Hyogo	ICPE2014	Kanazawa
ICPE2016	Hamamatsu	ICPE2018	Kamakura	ICPE2020	Online
ICPE2022	Nara	ICPE2024	Sendai		

Professor Norio Taniguchi

May 27, 1912-November 15, 1999

Coined the term "nano-technology" in 1974

European Society for Precision Engineering and Nanotechnology Lifetime Achievement Award **Scientific career**

Professor, Tokyo University of Science

https://en.wikipedia.org/wiki/Norio_Taniguchi

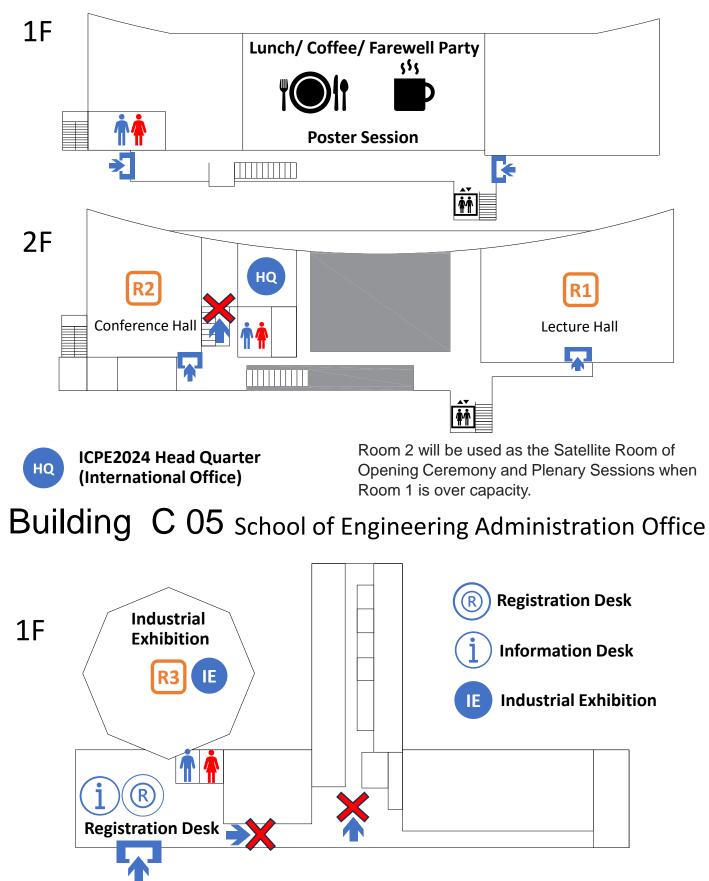
The 50th anniversary of birth of "Nano-technology"

Prof. Norio Taniguchi presented this paper of nanotechnology concept, for the first time in history, at the first ICPE conference of 1974 (ICPE1974, Tokyo) as: "nanotechnology mainly consists of the processing of separation, consolidation, and deformation of materials by one atom or one molecule"

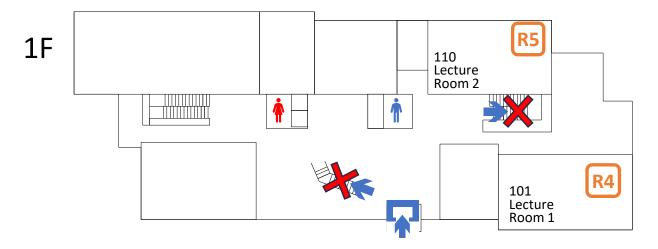
https://www.jspe.or.jp/wp_e/about_us_e/history/

	TABLE OF CONTENTS DNC and Automated Manufacturing System Problems in besigning Integrated Manufacturing Systems for Match Production C. de Beer (Muthrianda) Controlling of Automated Manufacturing Systems by Using an Expanded DNC-Syst C. Spur, A. Nitolia, F. Satrove (Germany) CM Systems in thannood Factories I. Togino (Apan) Nano-technology in Materials Processing (Ultra-fine Finishing) Data Basic Concept of "Mano-technology" N. Tailpubli (Japan) Seme Data Basic Concept of Mano-technology Grind Laboration of Data Basuremant of Surfaces Using Stylus Techniques Mitebouse (U.K.) Crinic Physics Provelopment of a Model of Grinding D. Dyte, L. Samuelis (Australia) Institical Mechanian of Chip Formation in Grinding Process Physics Concertion Process in Grinding D. Concertion Process In Cristing D. Concertion Process In Chinding D.	Proceedings of The International Conference on Production Engineering Tokyo 1974 (PART II)
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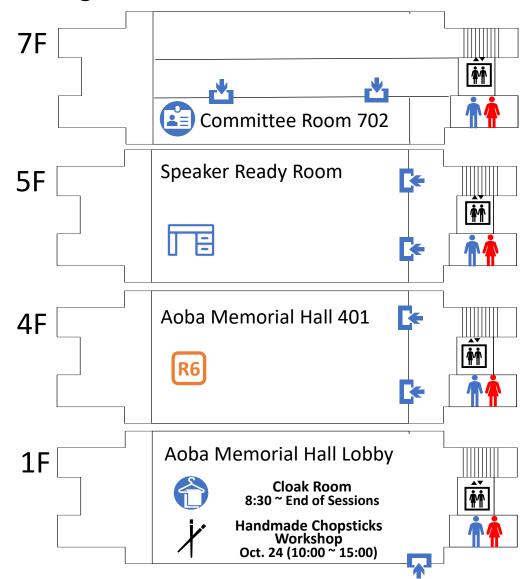
Building C 01 School of Engineering Center Hall



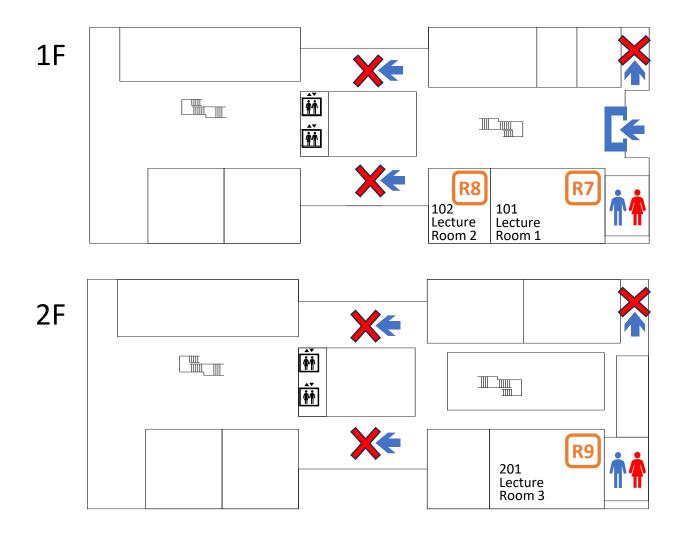
Building C 10 Engineering Laboratory Complex Building



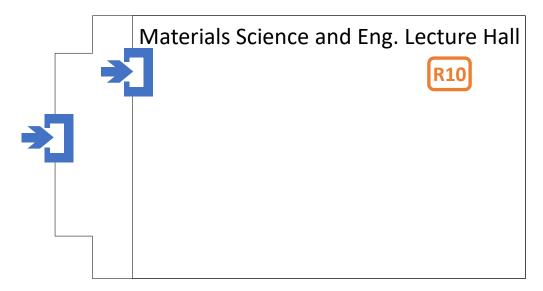
Building C 03 Aoba Memorial Hall



Building B 01 Materials Science and Eng. Education and Research Building



Building B 03 Materials Science and Eng. Lecture Hall



Building B 02 Rutsubo Hall



2F: Rutsubo Hall 1-A 1-B 2-A 2-B Bento (Lunch Box) Room (11:30 ~ 14:30)

Cafeteria / Lunch Box (Bento) Information

2024/10/24(Thu) Lunch Box (Bento) *The selection cannot be changed	Lunch Voucher @Aoba dining (Cafeteria) &2,000 JPY > Pater 2024/10/24(Thu) by 2 pp	
ICPE2024	Hand this voucher to the cashier. * Any excess must be paid in cash. * This voucher is non-refundable. 202410-561200 Tohoku Univ.SCOP	
2024/10/25(Frl) Lunch Box (Bento) * The selection cannot be changed	Lunch Voucher @Aoba dining (Cafeteria) & 2,000 JPY > Date:-2024/10/25/Fril by 2 p.m.	B 02
ICPE2024	Hand this vouched the paid in vouce Any excess must be paid in vouce This voucher is non-refundable. 202410-561200 Tohoku Univ.CCOP	
2024/10/26(Sat) Lunch Box (Bento) *The selection cannot be changed	Lunch Voucher @Aoba dining (Cafeteria) & 2,000 JPY> Date2024/10/26(Sat) by 2 p.m. How to use Hand this voucher to the cashier.	
ICPE2024	* Any excess must be paid in cash. * This voucher is non-refundable. 202410-561200 Tohoku Univ.COOP	C 01

1.During the reception, attendees will receive a Lunch Ticket corresponding to the information registered by them in advance.

2.Attendees who have chosen the lunch box option can use their Lunch Ticket to collect a lunch box(bento) at building B02 2F but cannot use the voucher on the right side of the Lunch Ticket at the Cafeteria.

3.Attendees who have selected the Cafeteria option can use the voucher on the right side of the Lunch Ticket at building CO1 1F to purchase a lunch worth up to 2000 JPY, but they will not be able to collect a lunch box.



Social Events

Welcome Reception

Date:	Wednesday, 23 October
Time:	18:30 - 20:00
Venue:	4F Sendai Hall, Hotel Metropolitan Sendai
Address:	1-1-1 Chuo, Aoba Ward, Sendai 980-8487
Tel:	022-302-3373

Dress code: Business casual

Catch up with colleagues and friends at this first networking opportunity at ICPE2024. A buffet-style meal will be provided.





Map to Hotel Metropolitan Sendai

Banquet

Date: Friday, 25 Octobe	r
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Time: 18:00 – 20:45

Venue: 4F Sendai Hall, Hotel Metropolitan Sendai

Dress code: Semi-formal

Enjoy an elegant dinner, seated and served, along with special entertainment.



Farewell Party

- Date: Saturday, 26 October
- **Time:** 18:10 19:30

Venue: Building C01 1F

Dress code: Semi-formal, Business casual

Savor the final night of ICPE2024 with old and new friends/ colleagues. A buffet-style meal will be provided.





Map to the Venue

Technical/ Excursion Tours

- The Technical/ Excursion Tours are free of charge.
- The Technical/ Excursion Tours are fully support from the Japan Tourism Agency.

Course information

Course ①: NanoTerasu campus/ Tohoku University and Akiu Sightseeing

Dates: October 22 (Day 1 Optional) - 23 (Day 2), 2024 Participants: 50 persons Schedule:

Day 1 (Optional): Accommodation at Metropolitan Sendai East, Comfort Hotel Sendai West, or ANA Holiday Inn Sendai (Accommodation subject to change)

Day 2:

•09:00: Sendai Station

- •09:30-11:30: NanoTerasu campus/Tohoku University
- •12:00-13:00: Lunch (Gyutan)
- •13:40-14:50: Sendai Kaleidoscopes Art Museum
- •15:10-16:00: Akiu Great Falls
- •17:00: Section meeting at Sendai Station

Transportation: Bus Meals: Lunch included



Course ②: NanoTerasu campus/ Tohoku University and Earthquake Ruins

Dates: October 22 (Day 1 Optional) - 23 (Day 2), 2024 **Participants:** 50 persons

Schedule:

Day 1 (Optional): Accommodation at Metropolitan Sendai East, Comfort Hotel Sendai West, or ANA Holiday Inn Sendai (Accommodation subject to change) Day 2:

- •09:00: Sendai Station
- •09:40-11:00: Maple Pavilion
- •11:30-12:20: Sendai 3/11 Memorial Community Center
- •12:30-13:30: Lunch (Rokuchonome Farm)
- •13:50-14:50: Ruins of the Great East Japan Earthquake Sendai Arahama Elementary School
- •15:20-17:00: NanoTerasu campus/Tohoku University
- •17:20: Section meeting at Sendai Station
- Transportation: Bus

Meals: Lunch included





Course information

Course ③: JAXA and Zao Sightseeing

Dates: October 22 (Day 1 Optional) - 23 (Day 2), 2024 **Participants:** 50 persons **Schedule:**

Day 1 (Optional): Accommodation at Metropolitan Sendai East, Daiwa Roynet Hotel Sendai-nishiguchi PREMIER, or ANA Holiday Inn Sendai (Accommodation subject to change)

Day 2:

- •09:00: Sendai Station
- •10:00-11:15: Kakuda Space Center
- •11:45-12:45: Lunch (Denen)
- •14:00-15:00: Okama Crater
- •15:30-16:10: Zao Kokeshi Museum
- •17:00: Section meeting at Sendai Station Transportation: Bus Meals: Lunch included



Course (4): Sake Brewery and Matsushima Sightseeing

Dates: October 22 (Day 1 Optional) - 23 (Day 2), 2024

Participants: 50 persons

Schedule:

Day 1 (Optional): Accommodation at Metropolitan Sendai East, Hotel Monte Hermana Sendai, or ANA Holiday Inn Sendai (Accommodation subject to change) Day 2:

•09:00: Sendai Station

- •10:20-11:10: Sake Brewery Tour: Ichinokura
- •11:40-12:40: Lunch (Matsushima Rikyu)
- •13:00: Matsushima Coast
- •13:50-16:00: Matsushima Coast, Godaido Temple, Zuiganji Temple, Entsuin Temple
- •17:00: Section meeting at Sendai Station

Transportation: Bus, Boat, On foot

Meals: Lunch included





Plenary Chairs



Prof. Fengzhou Fang

Tianjin University University College Dublin Past President of CIRP



Prof. Andreas Archenti

KTH Royal Institute of Technology President of euspen

Plenary Speakers



Prof. Andreas Fischer University of Bremen PS1 Optical precision metrology for the production of microstructures



Prof. Daewook Kim University of Arizona PS2 Extreme optical engineering for giant telescopes



Prof. Anthony Beaucamp Keio University PS3 AI in Precision Engineering: Recent Trends and Challenges

Keynote Speakers



Prof. Bernhard Karpuschewski

University of Bremen KS1-1 Application of coarsegrained grinding wheels for precision grinding of glassy carbon



Prof. Hitomi Yamaguchi University of Florida KS1-2 Polishing of Hardened Steel Components using Magnetic Abrasive Finishing



Prof. Erhan Budak Sabancı University KS1-3 Experimentally backed simulation of textured CBN grinding wheels for enhanced performance



Prof. Lihui Wang KTH Royal Institute of Technology KS2-1 Latest Advancement on Human-Robot Collaboration in Manufacturing

Keynote Speakers



Prof. Xichun Luo

University of Strathclyde KS2-2 Digital twin-driven ultra precision manufacturing system



Prof. Samanta Piano

University of Nottingham KS2-3 Enhancing in-process monitoring of additive manufacturing through virtual fringe-projection simulations



Prof. Robert Gao Case Western Reserve University KS3-1 Deformation prediction in English wheeling through physicsinformed machine learning



Dr. Daniel Meyer

IWT Bremen KS3-2 Precision in Microtexturing: A Machine Learning Approach to Optimize Surface Parameters and Milling Techniques for Enhanced Topography



Prof. Jean-Marc Linares Aix-Marseille University KS3-3 How can nature help us find mechanical solutions: Sustainable,



Prof. José A. Yagüe-Fabra

University of Zaragoza KS4-1 Influence of relative intensity in metal-polymer assembly evaluation by X-ray computed tomography



Prof. Giovanni Moroni

resilient and frugal

Politecnico di Milano KS4-2 Comparative analysis of surface determination techniques in coordinate metrology with X-ray computed tomography



Dr. Gaoliang Dai

Physikalisch-Technische Bundesanstalt KS4-3 Top-down and bottom-up traceability approaches for applied nanodimensional metrology



Prof. Enrico Savio University of Padua KS5-1 Integrated metrology in manufacturing: connecting digital twins and applications in metal forming



Prof. Benny C.F. Cheung

The Hong Kong Polytechnic University KS5-2 Advances in Autostereoscopic Freeform Surface Metrology



Dr. Jaspreet S. Dhupia The University of Auckland KS5-3 Modelling and control of the occlusal force for simulating voluntary chewing by a robot

Feature Speakers



Dr. Thomas Liebrich

RhySearch FS1-1 Laser machining of optical elements



Dr. Reina Yoshizaki

The University of Tokyo FS1-2 Formation mechanism of Optical Waveguide in α -Quartz by Ultrashort Pulse Laser



Dr. Chieko Kuji Tohoku University FS1-3 Notch effect in blanking of local heating with ultrashort pulsed laser for Fe-based amorphous alloys and its influence on soft magnetic properties



Dr. Jufan Zhang University College Dublin FS2-1 Atomic and Close-to-atomic Scale Manufacturing of Large-scale Solid-state Nanopore Array



Prof. Zhiyu Zhang Changchun Institute of Optics, Fine Mechanics and Physics FS2-2 Fabrication of membrane optics by diamond turning combined with spin molding



Prof. Hao Wang National University of Singapore FS2-3 Development of Augmented Ultraprecision Machining Technology



Prof. Burak Sencer Oregon State University FS3-1 Accurate prediction of 5axis machining cycle times with machine learning



Prof. Peng Wang

Case Western Reserve University FS3-2 Efficient and Generlizable Machine Learning for Inline Defect Detection in Battery Laser Welding



Prof. Xi (Vincent) Wang KTH Royal Institute of Technology FS3-3 Design of an RFID-based part identification approach: a case study in an automotive manufacturing plant



Korea National University of Science and Technology FS4-1 Multi-wavelength

Dr. Jonghan Jin

interferometer for measuring absolute distances using numerous frequency modes of the electro-optic comb



Prof. Xin Xiong Chongqing University of Technology FS4-2 Research on conjugate differential interferometric selfcalibration method for large-scale planar variable-line-spacing gratings



Dr. Giacomo Maculotti

Politecnico di Torino FS4-3 Towards Nanoindentation Metrological Digital Twin: traceable automated procedure for out-ofcontrol measurements identification

Feature Speakers



Dr. Supat leamsupapong

King Mongkut's University of Technology North Bangkok FS5-1 Role of surface finish on corrosion properties of dissimilar welding of stainless steels



Dr. Peerapong Kasuriya

King Mongkut's University of Technology Thonburi FS5-2 Investigation of surface characteristics of mirror-finished surfaces using polycrystalline sintered diamond ball end mill



Dr. Chunjin Wang The Hong Kong Polytechnic University FS5-3 Fluid jet polishing of functional structured surfaces



Dr. Atsushi Ezura

Sanjo City University FS6-1 Laser-induced Wet Surface Treatment using Aluminum Nitrate Aqueous Solution for Improvement of Wear Resistance of Titanium Alloy



Dr. Yunlong Tang Monash University FS6-2 Additive Manufacturing of Multi-Scale Porous Gyroid Infill Structures with Tailored Hardness



Mr. Julien Diperi

Aix-Marseille University FS6-3 How does additive manufacturing combine with bioinspiration for design innovation?



Dr. Fatma Nur Depboylu University of Southern Denmark FS6-4 A new porous biomedical implant production process development for Laser Powder

Bed Fusion (L-PBF) Technology



Prof. Chao-Ching Ho

National Taipei University of Technology FS7-1 Enhancing Dataset Variability in Semiconductor Manufacturing through Domain Adaptation and Advanced Simulation Techniques



Dr. Rachele Bertolini University of Padova FS7-2 Enhanced Formability and Martensite Transformation in AISI 316 Stainless Steel at Sub-Zero Temperatures



Prof. Sangkee Min

University of Wisconsin-Madison FS7-3 Investigating the effects of crystallography on subsurface damage during ultra-precision machining of sapphire



Dr. Zekai Murat Kilic The University of Manchester FS7-4 Analytical cutting force prediction of axial ultrasonic vibrations-assisted milling of difficult-to-cut materials



Prof. Koji Iwamura Osaka Metropolitan University FS8-1 Verification of Effectiveness of Demand Forecast for Plant Factories

Feature Speakers



Dr. Ralf D. Geckeler

Physikalisch-Technische Bundesanstalt FS8-2 State of the art and novel approaches in angle metrology at the Physikalisch-Technische Bundesanstalt



Prof. Feng Gao

University of Huddersfield FS8-3 Error analysis for near optical coaxial phase measuring deflectometry with refraction error model



Prof. Ryo Sato Tohoku University FS8-4 Second harmonic confocal probe with a mode-locked femtosecond laser



Dr. Ankit Kumar IIT Bombay FS9-1 Enhancing Wear Resistance of IN 625 Alloy Through Parameter Optimization in Wire Arc Additive Manufacturing



Dr. Osamu Sato National Institute of Advanced Industrial Science and Technology FS9-2 Optimization of multipleorientation dimensional measurement on X-ray CT



Prof. Charyar Mehdi-Souzani

Université Paris-Saclay USPN FS9-3 Aggregation-value-based active sampling method for multisensor freeform surfaces measurement and reconstruction



Dr. Yindi Cai

Dalian University of Technology FS9-4 Volumetric error modeling and compensation for nine-axis and five-linkage turn-milling compound machine tool



Dr. Xiaohua Liu The Chinese University of Hong Kong FS10-1 Sol Gel Glass Micro and

Metasurface Fabrication



Prof. Masanori Kunieda National Institution for Academic Degrees and Quality Enhancement of Higher Education FS10-2 Measurement of discharge reaction force acting on wire electrode in wire electrical discharge machining



Dr. Wijayanti Dwi Astuti

Universitas Gadjah Mada FS10-3 Theoretical Inquiry of Type II SHG Phase Matching Angle of LBO Crystal for Small Angle Detection



Dr. Kefei Wen The University of British Columbia FS10-4 Kinematically Redundant (6+3)-DOF Hybrid Parallel Robots with Very Large Rotational Workspace

Instruction for Oral Presentation

The 20th International Conference on Precision Engineering (ICPE2024) in Sendai

[Presentation/ Discussion time]

Plenary paper: 40 min / 5 min. Keynote paper: 25 min / 5 min. Feature paper: 20 min / 5 min.

Ordinary paper: 15 min / 5 min.

During the 20 minutes (15+5) of an ordinary paper, there will be three time reminders of bell ring. The first bell will ring at 12 minutes, the second at 14 minutes, and the third at 19 minutes. After the third bell, please finish the answer within 1 minute and proceed to the next presentation.

[Slide format]

Please make your presentation slides using Microsoft PowerPoint. No official slide template is provided in ICPE2024.

[PC and file upload]

It is recommended that presenters bring their own laptops for presentation to prevent the spread of computer viruses. Please check the connection and your presentation-slides during a break with the help of conference staffs. You can also use the public laptop PC with Windows OS equipped in each session room. In that case, please upload your PowerPoint presentation file to the PC by your USB memory before your session begins.

Instruction for Poster Presentation

The 20th International Conference on Precision Engineering (ICPE2024) in Sendai

[Date & Time & Place]

Oct. 26th, 15:30-16:30 JST, at Building C01 1F&2F Display time:

Setup time: Oct. 26th, 9:00 - 15:30 JST Removal time: Oct. 26th, 16:30-17:00 JST

[Poster preparation]

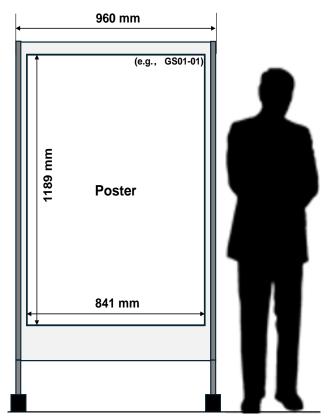
An A0 size poster is recommended to fit the size of the exhibition panel. No official template for the design of the poster as well as the font format and size. However, please write your Reference No. (80 pt bold for A0 size poster) in the top right corner of the poster. Please print and bring posters with yourselves.

[Posting of posters]

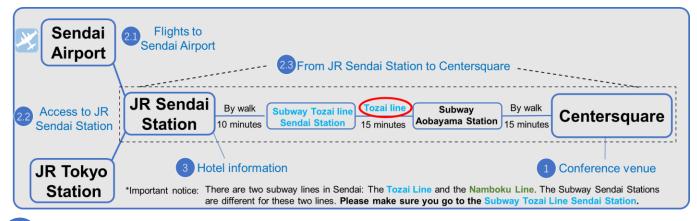
Authors are expected to stand by their posters during the session to answer questions and engage with attendees. Please do not leave your poster place during the session time.

[Awarding]

A Best Poster Award of ICPE2024 will be selected based on the poster quality among those who submitted a full paper.

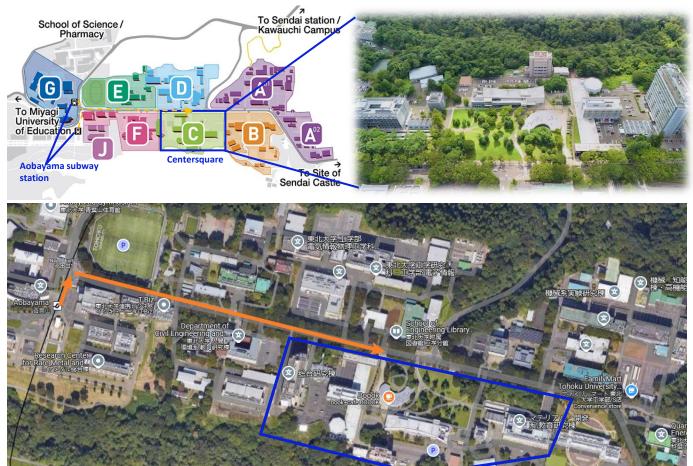


Conference Venue



Conference Venue

Centersquare, School of Engineering, Tohoku University



Tohoku University Aobayama Campus Map

School of Engineering, Tohoku University is located in Aobayama Campus, a few kilometers west of the center of Sendai city with direct subway-connection to the city center. Aobayama Campus aims for an "Environmental-Harmony-Campus" and considers the preservation of natural environments in Aobayama.

>> Tohoku University

>> School of Engineering, Tohoku University

Access to Sendai

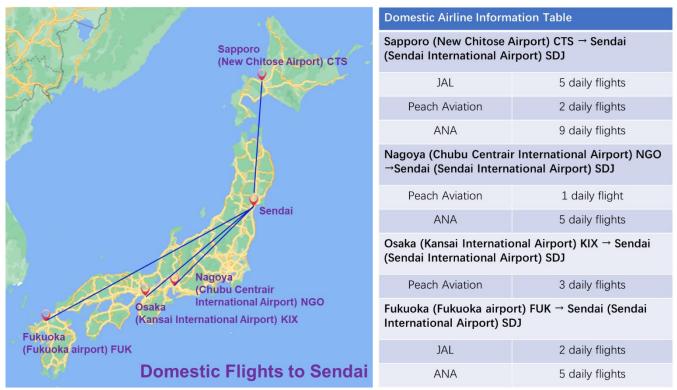


Flights to Sendai Airport

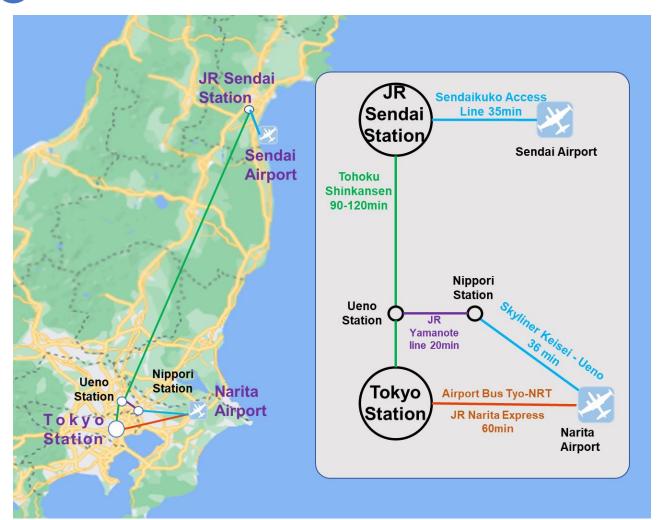
International Flights to Sendai



Domestic Flights to Sendai







- From Sendai Airport to JR Sendai Station
 - You can take "Sendaikuko Access Line" to JR Sendai Station
 - Approximate time : 35 minutes
 - Fare : 660 Yen
 - >> Sendai Airport
- From Tokyo Airports (Narita/ Haneda) to JR Sendai Station

- Plan 1: Take "<u>JR Narita Express</u>" to JR Tokyo Station, then take "Tohoku Shinkansen" to JR Sendai Station.

- Plan 2: Take "<u>Airport Bus Tyo-NRT</u>" to JR Tokyo Station, then take "Tohoku Shinkansen" to JR Sendai Station.

- Plan 3: Take "<u>Skyliner Keisei-Ueno</u>" to Nippori Station, then take "JR Yamanote Line" to Ueno Station, finally take "Tohoku Shinkansen" to JR Sendai Station.
- For more information, please refer to
 - >> East Japan Railway Company
 - >> <u>Narita Airport</u>
 - >> Tokyo Haneda Airport

2.3 How to purchase Shinkansen tickets?

1. Buy tickets at JR Stations:

There are many Shinkansen Trains connecting Tokyo and Sendai, and there is no worry about not being able to catch a train at Tokyo Station. You can buy a Shinkansen ticket from Tokyo to Sendai on the same day before boarding the Shinkansen at JR Tokyo Station from a JR ticket office or a JR ticket machine at Tokyo JR Station or any JR Station in Tokyo or the airports.

It is suggested to buy a ticket in a ticket office from an office staff member if you are not familiar with the train systems in Japan. You can also use a ticket machine that typically has an English menu. Please notice that not all machines are the same, as some only offer Shinkansen tickets, and others only offer seat reservations.

There are two types of Tohoku Shinkansen trains (Faster or Slower) you can take from Tokyo to Sendai:

Faster trains: "Hayabusa", "Hayate" or "Komachi" with only reserved seats, which takes approximately 1.5 hours from Tokyo to Sendai.

Slower trains: "Yamabiko" with both reserved and non-reserved seats, which takes approximately 2 hours or 2.5 hours from Tokyo to Sendai.

There is basically no limitation in the number for the non-reserved seats of the "Yamabiko" trains. You can board any of the Yamabiko trains for the non-reserved seats, although you need to purchase the ticket before boarding.

For more details, please check the following website: Shinkansen tickets: How to buy and use.

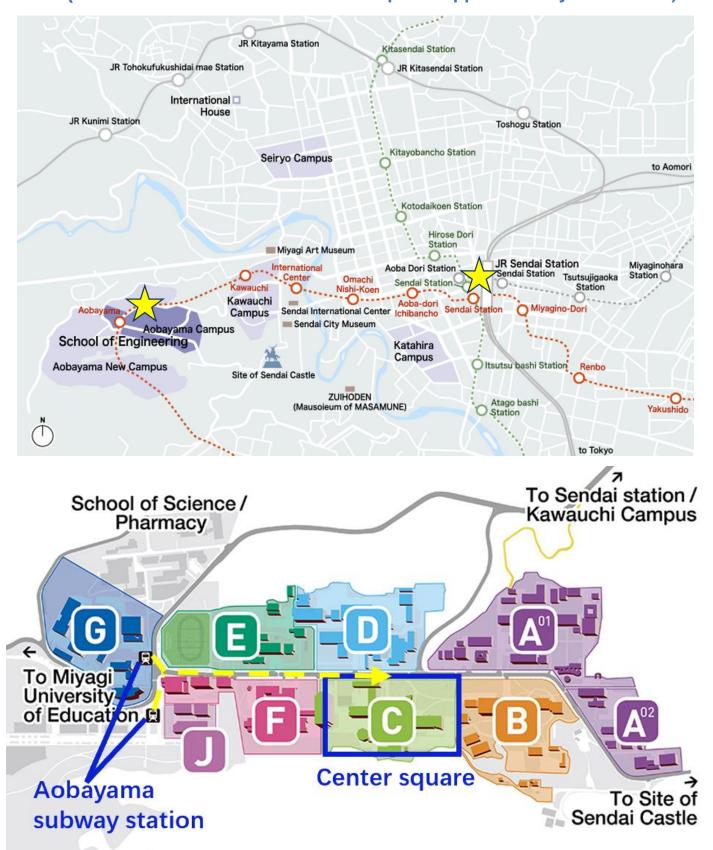


2. Buy tickets online:

The following is the website that allows you to purchase Shinkansen tickets before or on the day of boarding:

JR-East Train Reservation

2.4 Access to the Conference Venue (Access Map) (From JR Sendai Station to Centersquare: approximately 40 minutes)



2.4 Access to the Conference Venue (Subway information) (From JR Sendai Station to Centersquare: approximately 40 minutes)

• As an environment-friendly and a convenient means of transportation, public subway will be utilized in ICPE2024 for transportation. A rechargeable IC card (icsca) will be provided at the Conference Registration for three round-trips of subway between Subway Sendai Station and Subway Aobayama Station (the Conference Venue).

• Please take the Subway Tozai Line from Subway Sendai Station to Subway Aobayama Station. Please note that the JR/ Shinkansen platforms at JR Sendai Station and the subway platforms are on different floors. Please follow the following instruction to walk from the JR/ Shinkansen platform to the subway station to take the subway.

• Below are the specific directions for the route.

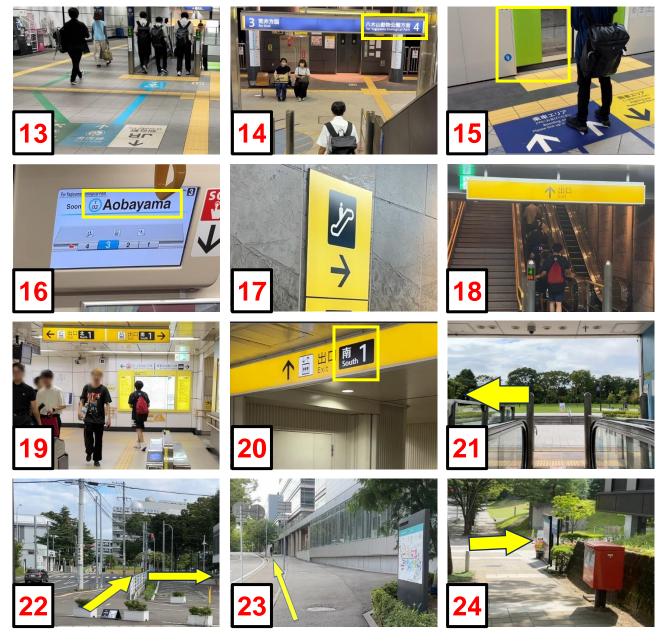


• Please note that before entering the ticket gates, you need to purchase a subway ticket or use a transportation IC card to pass the gates. The subway ticket vending machines are located to the right of the ticket gates.

• Please make sure you go to the Subway Tozai Line Platform.

The 20th International Conference on Precision Engineering (ICPE2024)

The 50th Anniversary of ICPE & Nanotechnology



• Take the subway in the direction of **Yagiyama Zoological Park** and get off at **Aobayama Station**. Then, follow the signs to exit from **South Exit 1** and proceed towards Centersquare according to the directional arrows.

• Walk from JR Sendai Station to Subway Sendai Station (Tozai Line) within the JR Sendai Station Complex

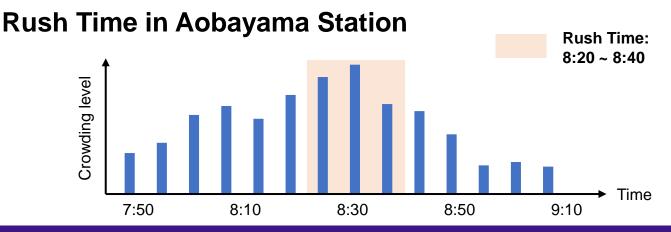
- Approximate time : 10 minutes
- Take Sendai subway Tozai Line bound to "Yagiyama Zoological Park" and get off at "Aobayama station"
- Approximate time : 15 minutes
- Fare : 250 Yen
- Walk from "Aobayama station" to Centersquare (the conference venue)
- Approximate time : 15 minutes

Caution: No car parking spaces will be provided in the Conference Venue.

Timetable of Subway Tozai line

	Sendai 🗲 Aobayama																			
	Weekday											١	Ne	ek	en	d				
5	49										5	49								
6	02	14	24	33	42	50	59				6	02	15	26	35	43	51	59		
7	06	14	21	27	33	38	43	48	53	59	7	07	15	23	31	39	47	55		
8	04 58	10	15	21	26	32	37	42	47	53	8	03	11	19	27	35	43	51	59	
9	04	09	15	23	31	39	47	55			9	07	15	23	31	39	47	55		
10	03	11	19	27	35	44	54				10	03	11	19	27	35	44	54		
11	04	14	24	34	44	54					11	04	14	24	34	44	54			
12	04	14	24	34	44	54					12	04	14	24	34	44	54			

	Aobayama 🗲 Sendai																	
	Weekday												N	Ne	ek	end		
15	00	08	16	24	32	40	48	56			15	05	15	25	35	45	55	
16	04	12	20	28	36	43	49	55			16	05	15	25	35	45	55	
17	01	07	13	19	25	31	37	43	49	55	17	05	15	25	35	45	55	
18	01	07	13	19	25	31	37	43	49	55	18	05	15	25	35	45	55	
19	01	07	13	19	25	31	37	43	49	55	19	05	15	25	35	45	55	
20	01	07	13	19	27	35	43	51	59		20	05	15	25	35	45	55	
21	07	15	23	31	39	47	55				21	05	15	25	35	45	55	
22	03	11	19	27	35	43	55				22	05	15	25	35	45	55	



Weather & General information

Weather

In Sendai, during late October, the weather tends to be cool and crisp, as autumn is in full swing. Based on historical weather data, the average temperature ranges between 10°C to 19°C in Sendai central region, with some days dipping slightly cooler, especially in the mornings and evenings. The temperature can be much lower in mountains, such as the Zao Mountain in the ICPE2024 Technical Tour Course ③.

Clothing recommendation

- Layering is key: A long-sleeve shirt with a jacket would be good for daytime. Adding lightweight coat and/or light sweater would be good for mornings and evenings. Winter clothing would be necessary for mountains, such as the Zao mountain.
- Averagely **70%** of raining probability during the conference term (23-26, October), so it is strongly suggested to bring a small, packable **umbrella** or a waterproof jacket.

You can check the latest weather forecast on the Japan Meteorological Agency website: http://www.jma.go.jp/jma/indexe.html

Security

Japan is known for its low crime rate, but it is always wise to be careful of one's personal belongings, especially in crowded areas.

Drinking Water - Tap Water

Tap water is drinkable anywhere in Japan unless mentioned otherwise. Also, you can buy mineral water at convenience stores, supermarkets, and drink kiosks, etc.

Currency Exchange

The official currency in Japan is the YEN(¥) and only the Yen is accepted when paying in cash. Currency exchange is available at designated foreign exchange banks.

Credit Cards, Debit Cards, Travelers' Cheques and ATMs

Major credit cards such as VISA, MasterCard, JCB, Diners Club, and American Express are widely accepted in Japan. Most ATMs, particularly those in post offices and 7-Eleven convenience stores, accept major international credit cards. Please note: Some ATMs may not accept foreign cards, and foreign travelers are advised to exchange their currency in Japan before visiting rural or remote areas.

Electricity

The local power supply is uniformly 100 volts. The frequency is 50Hz in Sendai (Eastern Japan). The type of power outlet/ connector is "Type A" which is a two parallel-pronged type.

Consumption Tax

Consumption tax is 10%.

Taxis

Taxi fares start at approximately JPY 1100 with additional costs depending on distance covered and time elapsed. Payment is made when you reach your destination and the exact fare is shown clearly on the meter, for transparency and assurance. Tipping is not necessary at any time when taking a taxi.

Tipping Tipping is not necessary in Japan.

Smoking

Smoking is available only in the designated areas. Public transportation such as trains, buses and taxis are generally non-smoking. Most hotels have separated rooms, smoking or non-smoking.

Liability

The Organizing Committees and/or Conference Organizers will not be held liable for personal accidents or losses or damage to private property of registered delegates to the Conference. Delegates should make their own arrangements as regards personal insurances.

	To Where	Phone Number			
Emergency Calls	Police	110			
	Ambulance or Fire	119			



Evacuation information

In the event of a major earthquake during the conference, it is important to protect yourself and avoid injury. Please take the following actions to ensure your safety.

Actions to Protect Yourself

If you are in a lecture room:

- Protect your head with a bag or other items.
- Move to a safe place nearby, such as under a desk or in a hallway, to ensure your safety.
- If you are near a window, move away from it to avoid injury from shattered glass.
- Do not rush outside, as there is a risk of glass from the doors or exterior walls falling.

If you are in a large classroom or conference room:

- · Protect your head with clothing or belongings to avoid injury from falling light fixtures or ceiling materials.
- Move to areas near pillars, walls, or stair landings.

If you are in an elevator:

- Press the button for the nearest floor or all floors, and exit on the floor where the elevator stops, using the stairs to evacuate.
- If you become trapped, use the intercom in the elevator to call for help.

When you hear the Earthquake Early Warning (an alarm will be announced on campus if the estimated seismic intensity is 4 or higher):

- Assess the situation around you and move away from areas with a risk of falling or toppling objects.
- Protect your head with a bag, or other items, and remain still to ensure your safety.

Evacuating to Outdoor Evacuation Area

Once the earthquake subsides, promptly evacuate the building and move to the designated outdoor evacuation area to ensure your safety.

Points to note during evacuation:

- Debris, such as scattered objects and wall fragments, may be present in hallways and on stairs, so act calmly and do not run.
- Gather at the Evacuation Area (refer to the map).



Hotel Information

Sendai is one of the most popular destinations of tourists in Japan. October is a high season in Sendai for tourists and events. **It is strongly suggested to book your hotel at your earliest convenience.** Basically, any of the hotels in the city center of Sendai (around the JR Sendai Station) would be convenient for a subway access to the Conference Venue. Any of the hotels in Sendai, from reasonable business hotels to luxury city hotels, is clean and safe. A list of hotels is provided in the following for your reference.

Recommended Hotels

- Hotel Metropolitan Sendai (40 min. to the conference venue of Centersquare by subway and walk)
- Hotel Metropolitan Sendai is the main hotel for ICPE2024 Social Program (Reception on October 23 and Banquet on October 25)

< 0 min. walk from JR Sendai Station > (Within the JR Sendai Station Complex)

Hotel Metropolitan Sendai :https://sendai.hotel-metropolitan.com/Hotel Metropolitan Sendai East :https://east-sendai.hotel-metropolitan.com/

- Hotel around JR Sendai Station: Map of hotels around Sendai Station Tohokukai Hospita *This map has been prepared based on information as of November, 2021. *Please contact the hotel directly for room availability and reservations. Tohoku Univ Seiryo Campu Accommodation facilities (SenTIA Supporting members) Accommodation facilities (Other) -Tohok mbers corresponds to the accommodation facilities und Sendai station' on the back of this map. JR Line Tourist Information a Ward Offic --- Subway Namboku Line 🖪 Hospital Miyagi Prefectural Offic Subway Tozai Line Museum 83 LOOPLE SENDAI Historical monument (21 LOOPLE SENDAI BUS STOP Anpanman Children's Museum endal City M 22 FUIISAKT 俞 Tohoku Univ. Kawauchi Hagi Hall Tsutsuji 8 Tohoku Univ wauchi Cam ndai Sunplaza â Si ÷ 血 Site of Sendai Castle (Aoba Castle Exhibition Hall) atahira Sakura Hai (Mausoleum of Date Masamune) Sendai City Welfare Plaza
- Hotel booking site:
 - Expedia Booking.com trivago

Printed version of map and list of hotels :
 Printed version of map and list of hotels

Hotel Information

· List of Hotels:

No Name	T E L Rooms	No Name	TEL	Rooms	ns No. Name TEL	Room		
HOTEL METROPOLITAN SENDAI	81-22-268-2525 295	35 The Westin Sendai	81-22-722-1234	on the second second				
HOTEL METROPOLITAN SENDAI EAST		36 Aisaki Ryokan (Inn)	81-22-264-0700			40		
Hotel Monterey Sendai	81-22-265-7110 206	37			66 SENDAI SUNPLAZA 81-22-257-3333			
WASHINGTON HOTEL SENDAI	81-22-745-2222 223	38 Oka no Hotel	81-22-256-7311	35		88		
HOTEL VISTA SENDAI	81-22-385-6222 238	41 Richmond Hotel Sendai	81-22-722-0055			78		
SENDAI GARDEN PALACE	81-22-299-6211 66	42 HOTEL SHIRAHAGI	81-22-265-3411	28	8 69 HOTEL Green Park 81-22-265-6171	72		
Comfort Hotel Sendai East	81-22-792-8711 202	43 SENDAI ROYAL MAYFLOWER	81-22-262-5411	182	2 70 HOTEL Premium Green SOVEREIGN 81-22-227-2322	92		
HOTEL Green Pacific	81-22-221-8888 92	Toyoko Inn Sendai Nishi-guchi	81-22-721-1045	210	71 Capsule Hotel Leaves 81-22-261-8020	120		
2 Richmond Hotel Premier Sendai Ekimae	81-22-716-2855 183	45 Hirose-dori	01-22-721-1045	210	73 SAUNA & CAPSULE CURE KOKUBUNCHO 81-22-713-8526	18		
B HOTEL Green Well	81-22-216-6155 47	46 Daiichi Inn Park	81-22-213-0089	85	74 Smile Hotel Sendai Kokubuncho 81-22-261-7711	20		
HOTEL UNISITE SENDAI	81-22-716-0123 144	48 HOTEL HOKKE CLUB SENDAL			75 Hotel Grand Terrace Sendai Kokubun-cho 81-22-262-7755	29		
HOTEL CENTRAL SENDAL	81-22-711-4111 97	Scheduled to close on January 5, 202			76 HOTEL Green With 81-22-261-3737	78		
5 SENDAI BUSINESS HOTEL STATION FRONT	81-22-262-3211 250	49 HOTEL Green Selec	81-22-217-3117			77		
7 HOTEL Green Mark	81-22-224-1050 140	51 R&B Hotel Sendai Hirose-dori Ekima				64		
Toyoko Inn Sendai-eki Nishi-guchi Chuo	81-22-726-1045 286	53 dormy inn EXPRESS Sendai Hirose-do	ri 81-22-715-7077	120	0 81 HOTEL PEARL CITY SENDAI 81-22-262-8711	16		
APA Villa Hotel Sendai-Eki Itsutsubashi	0570-023-111 610	55						
ANA Holiday Inn SENDAI	81-22-256-5111 165	56 Mitsui Garden Hotel Sendai	81-22-214-1131					
2 Hotel Grand Bach Sendai	81-22-296-0660 151	57 KOYO GRAND HOTEL	81-22-267-5111		9	Roon		
3 Toyoko Inn Sendai Higashi-guchi No.1	81-22-256-1045 208	60 Super Hotel Sendai / Hirosedori	81-22-224-9000		5 01 Decker Oberrarie 01 02 000 7000			
Toyoko Inn Sendai Higashi-guchi No.2	81-22-298-1045 120	61 HOTEL Premium Green Hills	81-22-722-1501					
HOTEL JAL CITY SENDAL	81-22-711-2580 238	62 HOTEL CROWN HILLS SENDAI AOBADO			4	0.		
Hotel Monte Hermana SENDAI	81-22-721-7501 275	63 Hotel Bel Air Sendai	81-22-217-8511	125				
B HOTEL Premium Green PLUS	81-22-212-1255 117				 Within 2,500 meters radius from Sendai Stn. 			
HOTEL KEIHAN SENDAI	81-22-263-0321 201				No. Name TEL	Roor		
ALMONT HOTEL SENDAL	81-22-212-6551 141				86 HOTEL Green City 81-22-219-2691	80		
Sendai Kokusai Hotel	81-22-268-1111 234				87 BANSUITEI IKOISO 81-22-222-7885	14		
		[Accommodation facilities	es (Other)]					
n Name		No. Name			No. Name			
Daiwa Roynet Hotel SENDAI		39 Hotel Palace Sendai			72 HOTEL LIVEMAX Kokubuncho			
Tenza Hotel Sendai Station		40 HOTEL PARK SENDAI II			77 9h nine hours Sendai			
APA Hotel TKP Sendai-Eki Kita		44 dormy inn Sendai Ekimae		80 HOTEL LIVEMAX Sendai Aobadori				
R&B Hotel Sendai Higashiguchi		47 Ryokan Tukasa		83 APA Hotel Sendai Kotodai Koen				
7 TOPOS		50 HOTEL LIVEMAX Sendai Hirosedori			85 Alpha Hotel in Jozenji			
1 Comfort Hotel Sendai West		52 dormy inn Sendai ANNEX						
2 LIBRARY HOTEL SENDAI-EKIMAE		54 Sendai Capsule Hotel Honcho						
3 HOTEL FOLIAGE SENIDAL		58 Daiwa Roynet Hotel SENDALICHIBA	NCHO					

33 HOTEL FOLIAGE SENDAI

- 58 Daiwa Roynet Hotel SENDAI-ICHIBANCHO59 Henn na Hotel Sendai Kokubuncho

* Please contact the hotel directly for room availability and reservations. * This map has been prepared based on information as of November, 2021.

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OS03	Advanced system design and applications	Toshiya Kaihara, Kobe University Masahiko Onosato, Hokkaido University Koji Iwamura, Osaka Metropolitan University Yoshiki Shimomura, Tokyo Metropolitan University Yutaka Nomaguchi, Osaka University Akira Tsumaya, Okayama Prefectural University
OS04	CAD/CAM technologies	Kouichi Morishige, The University of Electro-Communications Jun'ichi Kaneko, Saitama University Isamu Nishida, Kobe University Koichi Kikkawa, Kyushu Instutite of Technology Keigo Takasugi, Kanazawa University
OS05	Advanced cutting technologies	Takashi Matsumura, Tokyo Denki University Hiroyuki Sasahara, Tokyou University of Agriculture and Technology Katsuhiko Sakai, Shizuoka University Naohiko Sugita, The University of Tokyo Masato Okada, University of Fukui Katsuhiko Sekiya, Hiroshima University Norikazu Suzuki, Chuo University
OS06	Advanced grinding technologies	Lin Weimin, Gunma University Kazuhito Ohashi, Okayama University Hitoshi Ohmori, RIKEN Kazutoshi Katahira, RIKEN Naohiro Nishikawa, Iwate University Takayuki Kitajima, National Defense Academy of Japan Libo Zhou, Ibaraki University Keishi Yamaguchi, Kyoto Institute of Technology Takazo Yamada, Nihon University
OS07	Micro/Nano machining and figurings	Jiwang Yan, Keio University Kazuto Yamauchi, Osaka University Yutaka Yamagata, RIKEN Hirofumi Suzuki, Chubu Univeristy Keita Shimada, Nihon University Shuhei Kodama, Tokyo City University Keishi Yamaguchi, Kyoto Institute of Technology

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OS08	Nano-scale surface finishing	Syuhei Kurokawa, Kyushu University Hirokuni Hiyama, Ebara Corporation Michio Uneda, Kanazawa Institute of Technology Hitoshi Morinaga, FUJIMI FUJIMI Incorporated Kazuya Yamamura, Osaka University Jyunji Murata, Ritsumeikan University Yanhua Zou, Utsunomiya University Akihisa Kubota, Kumamoto University Urara Satake, Osaka University
OS09	Non-traditional machining and additive manufacturing	Tatsuaki Furumoto, Kanazawa University Kensei Kaneko, National Institute of Technology (KOSEN), Nagaoka College Toshiki Niino, The University of Tokyo Takeyuki Abe, Saitama University Tomohiro Koyano, Kanazawa University Ryo Koike, Keio University
OS10	Energy beam processing	Hirofumi Hidai, Chiba University Yasuhiro Okamoto, Okayama University Mitsugu Yamaguchi, Kanazawa University Yusuke Ito, The University of Tokyo Yuko Aono, Tokyo Institute of Technology
OS11	Advanced machine tools and elements	Yoshitaka Morimoto, Kanazawa Institute of Technology Keiichi Shirase, Kobe University Toshiki Niino, The University of Tokyo Yukitoshi Ihara, Osaka Institute of Technology Yohichi Nakao, Kanagawa University Yasuhiro Kakinuma, Keio University Ryuta Sato, Nagoya University Atsushi Matsubara, Kyoto University
OS12	Micro / Nano systems	Yuichi Nakazato, Nihon Insitutute of Technology Takahiro Ito, Kyushu Instutite of Technology Shinsuke Matsui, Chiba Institute of Technology Hidetsugu Terada, University of Yamanashi
OS13	Robotics and mechatronics	Naoki Asakawa, Kanazawa University Hiroaki Seki, Kanazawa University Toshiki Hirogaki, Doshisha University Daisuke Matsuura, Tokyo Institute of Technology
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OS15	Nano-scale measurements and calibrations	Yasuhiro Takaya, Osaka University Masaki Michihata, The University of Tokyo Soichi Ibaraki, Hiroshima University Terutake Hayashi, Kyushu University Panart Khajornrungruang, Kyushu Instutite of Technology So Ito, Toyama Prefectural University Ichiro Yoshida, Hosei University Yusuke Kajihara, The University of Tokyo Osamu Sato, AIST Hiraku Matsukuma, Tohoku University Yuki Shimizu, Hokkaido University

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OS16	Science and applications of nanostructure formation	Kenta Arima, Osaka University Jun Taniguchi, Tokyo University of Science Kimihisa Matsumoto, Toyama Prefectural University Masaki Michihata, The University of Tokyo
OS17	Mechano-photonics engineering and optical applications	Yukitoshi Otani, Utsunomiya University Yasuhiko Arai, Kansai University Toshiyuki Takatsuji, AIST Ichiro Ishimaru, Kagawa University Lianhua Jin, University of Yamanashi Motoharu Fujigaki, University of Fukui Masato Aketagawa, Nagaoka University of Technology Yusuke Kajihara, The University of Tokyo Masaki Michihata, The University of Tokyo
OS18	Advanced image processings and applications	Takashi Komuro, Saitama University Sarthak Pathak, Chuo University Akio Nakamura, Tokyo Denki University
OS19	Advanced 3 dimensional digital processing	Yutaka Ohtake, The University of Tokyo Hiroaki Date, Hokkaido University Hiroshi Masuda, The University of Electro-Communications Tomohiro Mizoguchi, Nihon University Yukie Nagai, Tokyo Metropolitan University
OS20	Advanced surface processing	Hiroaki Kakiuchi, Osaka University Naoto Ohtake, Tokyo Institute of Technology Yoshifumi Suzaki, Kagawa University Shozo Inoue, University of Hyogo
OS21	Micro fabrications for functional surfaces	Jun Shimizu, Ibaraki University Masahiko Yoshino, Tokyo Institute of Technology Arata Kaneko, Tokyo Metropolitan University Masanori Hayase, Tokyo University of Science Motoki Terano, Okayama University of Science
OS22	MEMS/NEMS	Takayuki Shibata, Toyohashi University of Technology Toshihiro Itoh, The University of Tokyo Kazuyoshi Tsuchiya, Tokai University Beomjoon Kim, The University of Tokyo Sung-Won YOUN, AIST Nobuhiro Kato, Kindai University
OS23	Bio-medical engineering and applications	Ichiro Sakuma, The University of Tokyo Seiji Aoyagi, Kansai University Masayoshi Muzutani, Tohoku University

Secretary Team



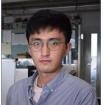
Tao Liu Third-year PhD student

Manage submissions in Google Drive, databases, information book, conference program, registration, Keynote/ Feature sessions, etc.



Yifan Hong Third-year PhD student

Response to the inquiry emails, invitation letters, visa documents, etc.



DongWook Shin Second-year PhD student

Managing bulk email distribution, database address, printing of certificates and awards, etc.



Jiucheng Wu Second-year PhD student

Preparation of the information book and conference rooms, banquet table arrangement, etc.



Chenguang Yin Second-year PhD student

Develop and maintain the official homepage, paper submission/ review systems, database for ICPE2024, preparation of registration desk, etc.



Jiahui Lin First-year PhD student

Manage submitted abstract, fulllength manuscripts, design the certification, database, list of participants, etc.



Zhiyang Zhang First-year PhD student

Develop and maintain the official homepage for ICPE2024, technical tours, newsletters, drone pictures, digital information center, etc.



Chen Li First-year Master student

Preparation of the conference program, program outline, participant badges, etc.



ICPE2024 23-26 October 2024, Sendai, Japan

Message from the Conference Chair

Dear ICPE2024 Participants,

On behalf of the Conference Committee, I would like to warmly welcome you to ICPE2024 being held at School of Engineering, Tohoku University, Sendai, Japan, from 23 to 26 of October, 2024.

The ICPE conference is organized by The Japan Society for Precision Engineering (JSPE). It has been successfully held 19 times since the 1st ICPE at Tokyo in 1994 where Prof. Norio Taniguchi coined the term of "Nanotechnology". I would like to thank Prof. Masanori Kunieda and JSPE for providing us the opportunity to host this year's ICPE in Sendai, a city called "Mori no Miyako" which means "City of Trees" for the gorgeous nature within the city. The invaluable advices from Profs. Atsushi Matsubara and Daisuke Kono, the Co-Chair and Secretary of ICPE2022 are highly appreciated.

More than 657 participants from 26 countries and regions will be attending ICPE2024. Half of the participants are from outside of Japan. 434 papers will be presented in 23 Organized Sessions and 16 General Sessions. I would like to thank all the invited Plenary/Keynote/Future Speakers and all the authors of the papers in the technical sessions for coming across the world to share their state-of-the-art research work covering a wide range of Precision Engineering, all the session organizers for organizing the sessions and all the reviewers for reviewing the papers.

ICPE2024 is co-organized by the School of Engineering, Tohoku University. ICPE2024 would not be possible without the support from the School of Engineering. Special thanks to Prof. Hiroo Yugami (Previous Dean), and Prof. Akinori Ito (Dean), Prof. Izumi Muto (Chair of The Department of Metallurgy, Materials Science and Materials Processing), Prof. Hirokazu Moriya (Vice Director of International Office) and many others for their kind understanding and generous supports. Prof. Yugami, now the Vice-President of Tohoku University, also helped to arrange the Technical Tours.

The financial supports from the premium ICPE2024 Sponsors listed in the Information Book are highly appreciated. I would also like to thank the Industrial Exhibitors and the advertising companies for their contributions to ICPE2024. The ICPE2024 Technical Tours are financially supported by The Japan Tourism Agency, Ministry of Land, Infrastructure, Transport. The assistance from Mr. Tabata Kentaro, Mr. Akihiko Shimanuki, Mrs. Miki Hasekawa and JTB are also appreciated.

Finally, I would like to thank all the members of the Conference Committee for their great efforts. Special thanks go to Conference Co-Chairs, Prof. Yuki Shimizu who organized the Technical Tours, Prof. Masayoshi Mizutani and Prof. Toshiyuki Takatsuji who organized the Industrial Exhibition, Sub Committee Chairs; Prof. Yasuhiro Mizutani, Prof. Masaki Michihata Prof. Ito So, Dr. Satoru Maruyama and Dr. Makoto Abe who took excellent leadership in each of the committees, Prof. Xin Xiong who did an excellent work for the arrangement of the participants from China, the largest group from outside of Japan. The most appreciation goes to the ICPE2024 Secretary Team, which is composed of my 8 talented Ph.D students and my assistant professor Ryo Sato. They have been working very hard with me for the preparation of ICPE2024 over the last one year and half.

ICPE2024 is a truly hand-made conference. It would be far from perfect and I would like to beg your forgiveness for the problems and issues occurring before and during the conference. Any suggestions and comments would be highly welcome. Hopefully ICPE2024 would be as successful as the previous ICPE conferences with the support from all the ICPE2024 participants.

Welcome to ICPE2024, The 50th Anniversary of ICPE & Nanotechnology!

Welcome to Tohoku University, Sendai, Japan!

Best regards,

ueigav

Wei Gao, Conference Chair, ICPE2024

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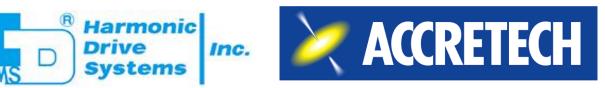












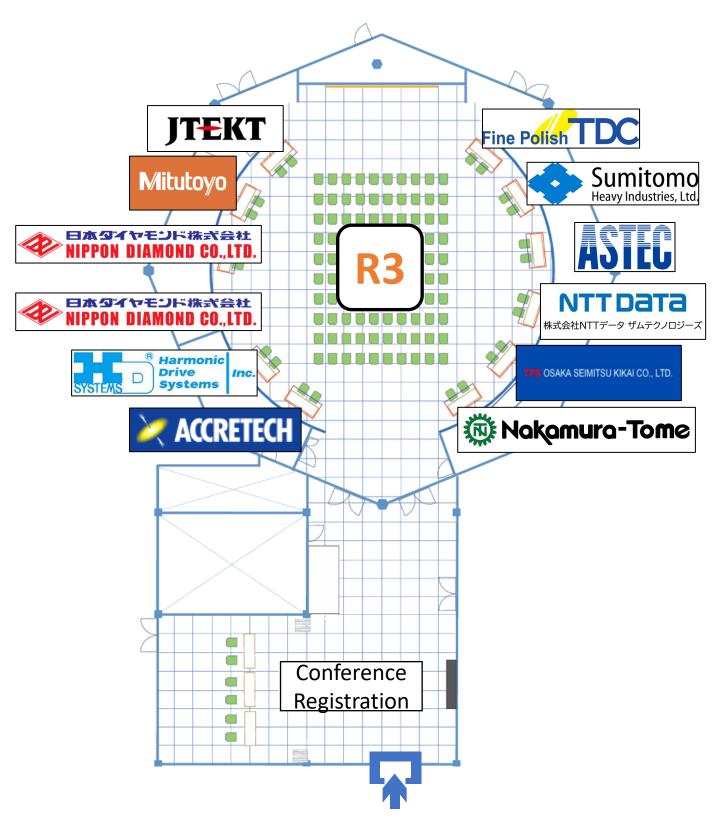
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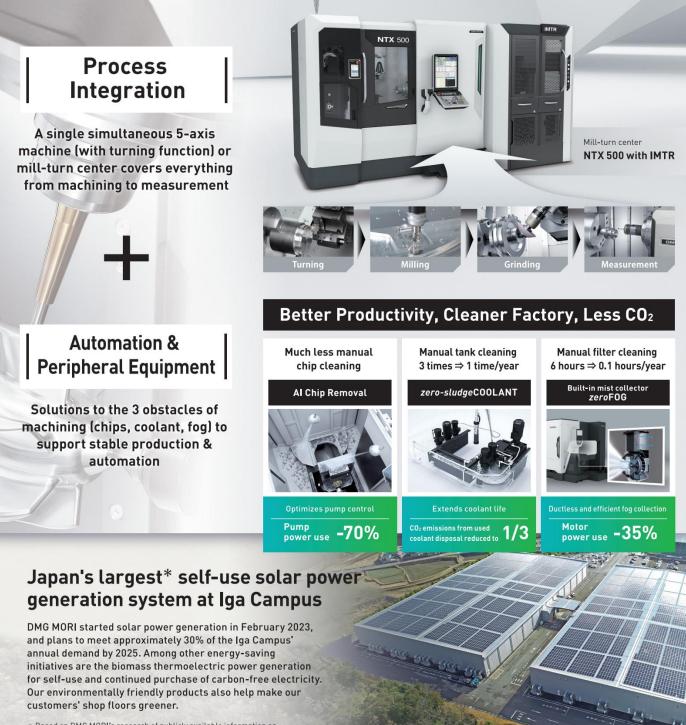
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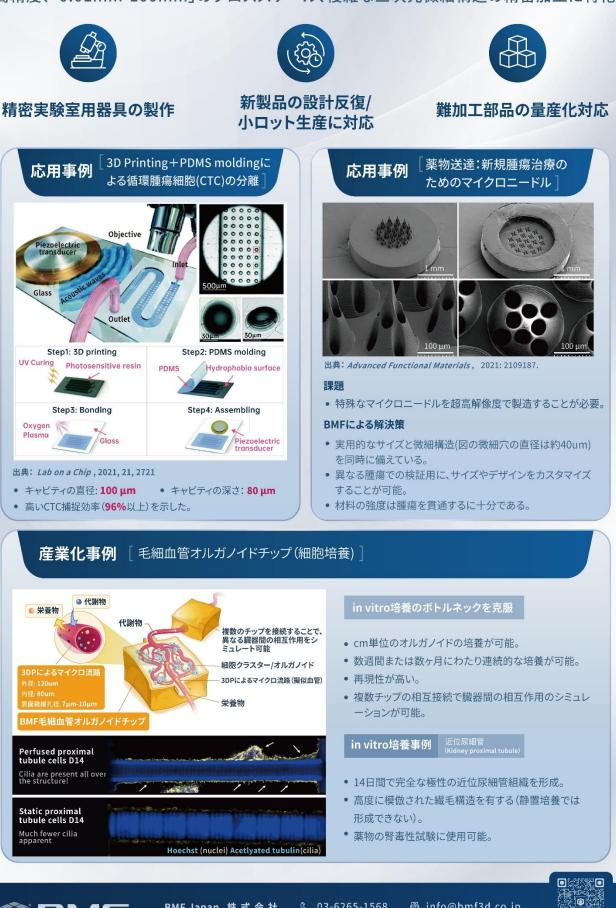
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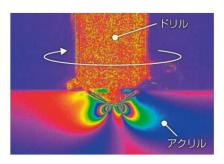
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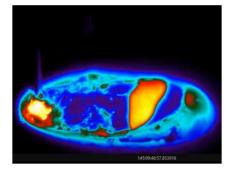
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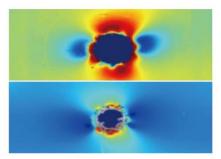
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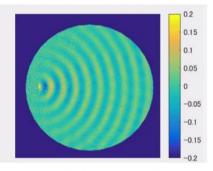
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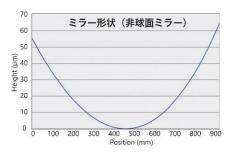
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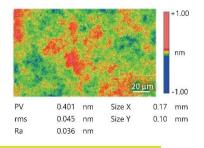
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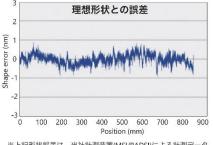
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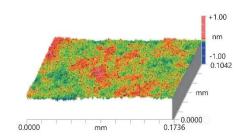
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